



Attorney Docket # 5367-47RCE

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan Bader et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: Method For Depositing A Material On A
Substrate Wafer

Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner: G. Nagesh Rao
Group Art: 1722

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 26, 2006

(Date of Deposit)

Thomas Langer

Name of applicant, assignee, or Registered Representative

Signature

December 26, 2006

Date of Signature

AMENDMENT UNDER 37 C.F.R. § 1.114

Sir:

Applicants hereby petition for a 2-month extension of the original shortened statutory response period set in the Office Action of July 24, 2006. Payment in the amount of \$450 for the government fee for a 2-month extension of time is enclosed herewith so that the period for response is extended to December 24, 2006. Any additional fees or charges required at this time in connection with the present application may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

RESPONSE

In conjunction with a Request for Continued Examination, this paper is submitted in response to the Advisory Action mailed November 22, 2006 and the Final Office Action dated July 24, 2006. No new matter has been added.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.